	Application No.	Applicant(s)
Notice of Allowability	09/746,065	INOUE ET AL.
	Examiner	Art Unit
	Armando Rodriguez	2828
The MAILING DATE of this communication appeal all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject	oplication. If not included n will be mailed in due course. THIS
 This communication is responsive to <u>Declaration filed Nove</u> The allowed claim(s) is/are <u>1-3 and 5-26</u>. The drawings filed on <u>26 December 2000</u> are accepted by Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents 	the Examiner. Ider 35 U.S.C. § 119(a)-(d) or (f). Ideo been received. Ideo been received in Application No	
International Bureau (PCT Rule 17.2(a)).		national stage application from the
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority un reference was included in the first sentence of the specifical	ation or in an Application Data Shee	• •
(a) The translation of the foreign language provisional a		
6. Acknowledgment is made of a claim for domestic priority up in the first sentence of the specification or in an Application		since a specific reference was included
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of	this communication to file a reply of this application. THIS THREE-MO	complying with the requirements noted NTH PERIOD IS NOT EXTENDABLE
7. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
 8. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No (b) including changes required by the proposed drawing c (c) including changes required by the attached Examiner's 	orrection filed, which has b	een approved by the Examiner.
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	• • • •	
9. DEPOSIT OF and/or INFORMATION about the depoattached Examiner's comment regarding REQUIREMENT FOR T		
Attachment(s)		
1☐ Notice of References Cited (PTO-892)	5 ☐ Notice of Informal P	atent Application (PTO-152)
 2 Notice of Draftperson's Patent Drawing Review (PTO-948) 3 Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No. 10-13-2003 	6☐ Interview Summary	(PTO-413), Paper No
	3), 7☐ Examiner's Amenda	nent/Comment
4☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	8⊠ Examiner's Stateme 9∏ Other .	ent of Reasons for Allowance PAUL IP
		FEMISORY PATENT EXAMINER FICHNOLOGY CENTER 2800

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DETAILED ACTION

Information Disclosure Statement

The information disclosure statement filed October 31, 2003 fails to comply with the provisions of 37 CFR 1.97, 1.98 and MPEP § 609 because the Japanese reference 9-083071 has not been provided with an English language translation. It has been placed in the application file, but the information referred to therein has not been considered as to the merits. Applicant is advised that the date of any re-submission of any item of information contained in this information disclosure statement or the submission of any missing element(s) will be the date of submission for purposes of determining compliance with the requirements based on the time of filing the statement, including all certification requirements for statements under 37 CFR 1.97(e). See MPEP § 609 ¶ C(1).

Response to Amendment

The declaration under 37 CFR 1.132 filed November 12, 2003 is sufficient to overcome the rejection of claim 1 based upon the 35 USC 103 rejection of Okuba et al in view of Hiroyama et al.

Allowable Subject Matter

Claims 1-3,5-26 are allowed.

The following is an examiner's statement of reasons for allowance:

After reviewing applicant's amendments, arguments and conducting an updated search examiner finds that none of the cited prior arts alone or in combination discloses

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the claimed semiconductor laser having the structural combination of independent claims 1, 7 and 17 with the structural interconnection of the active layer, cladding layer, current blocking layer, low carrier concentration layer and depletion layer as recited in claims 1, 7 and 17.

Regarding claims 1-3,5,6,8,9,12-16,

None of the prior arts alone or in combination discloses the claimed structural combination of dependent claim 1 having the depletion layer and a current blocking layer formed on the cladding layer except for the current injection region, where the depletion layer provides the function of inhibiting storage of carriers in a low carrier concentration layer and a depletion layer thickness of at least 10 nm.

Regarding claims 7,10,11

The following is a statement of reasons for the indication of allowable subject matter: None of the prior arts alone or in combination discloses the claimed structural combination of dependent claim 7 having the depletion layer, low carrier concentration layer and a current blocking layer successively formed on the cladding layer except for the current injection region, where the depletion layer provides the function of inhibiting storage of carriers in the low carrier concentration layer.

Regarding claims 17-26,

None of the prior arts alone or in combination discloses the claimed structural combination of dependent claim 17 having the depletion layer and the current blocking layer formed on the cladding layer except for the current injection region, where the depletion layer provides the function of inhibiting storage of carriers in a low carrier

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concentration layer with an energy bandgap for supplying second conduction type carriers and a depletion layer thickness of at least 10 nm.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Armando Rodriguez whose telephone number is 571-272-1952. The examiner can normally be reached on 10-hour day / M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Ip can be reached on 571-272-1941. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-

4881.

Afmando Rodriguez

Examiner-

Art Unit 2828

Paul lp

Supervisor

Art Unit 2828

AR/PI